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APPLICANTS

Kotaro Akutsu, Saitama, JAPAN;

Shin Matsui, Saitama, JAPAN;

**** CONTINUING DATA *********** FOREIGN APPLICATIONS *******

JAPAN 2002-210159 07/18/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED**** 10/07/2003**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <u><i>[Signature]</i></u> Examiner's Signature Initials	JAPAN	11	15	2

ADDRESS

5514
FITZPATRICK CELLA HARPER & SCINTO
30 ROCKEFELLER PLAZA
NEW YORK, NY
10112

TITLE

Electron beam exposure apparatus and semiconductor device manufacturing method

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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